

PATENT

Docket No.: 065933-0084

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277

Ryosuke USUI, et al. : Confirmation Number: 3812

Application No.: 10/813,629 : Group Art Unit: 2814

Filed: March 31, 2004 : Examiner: Dilinh P. Nguyen

For: SEMICONDUCTOR MODULE AND METHOD OF MANUFACTURING THE SAME

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

CERTIFICATION PARAGRAPH

The undersigned certifies that each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement as described in 37 CFR 1.97(e)(1).

Reference JP 2001-274293 A was cited in a corresponding foreign application office action and its relevance is discussed therein. A copy of the foreign office action, together with an English language version thereof, is attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP Bernard P. Cold (Reg. No. 46, 429) Stephen A Beston

Stephen A. Becker

Registration No. 26,527

Please recognize our Customer No. 20277 as our correspondence address.

600 13th Street, N.W. Washington, DC 20005-3096

Phone: 202.756.8000 SAB:ark

Facsimile: 202.756.8087

Date: February 28, 2007

By House B

SHEET 1 OF 1

SERIAL NO. INFORMATION DISCLOSURE ATTY. DOCKET NO. 10/813,629 065933-0084 CITATION IN AN **APPLICATION APPLICANT** Ryosuke USUI, et al. FILING DATE **GROUP** (PTO-1449) March 31, 2004 2814 U.S. PATENT DOCUMENTS **EXAMINER'S** CITE Document Number Publication Date Name of Patentee or Applicant of Cited Pages, Columns, Lines, Where INITIALS MM-DD-YYYY Relevant Passages or Relevant Number-Kind Code2 (# known) Document Figures Appear US US US บร US US US US ŪS US US US US บร FOREIGN PATENT DOCUMENTS **EXAMINER'S** Foreign Patent Document Publication Date Name of Patentee or Pages, Columns, Lines Translation INITIALS Applicant of Cited Document Where Relevant Country Code3-Number 4-Kind CITE MM-DD-YYYY Yes No Codes (if known) Figures Appear NO. JP 2001-274293 A 10-05-2001 HITACHI CHEM CO LTD JAPAN (w/English Abstract) OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.) **EXAMINER'S** Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, INITIALS journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where CITE NO. Japanese Office Action issued in corresponding Japanese Patent Application No. 20004-086770, dated November 28, 2006

DATE CONSIDERED

EXAMINER

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.